

Notice of References CitedApplication No.
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1753

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U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A					
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FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
N						
O						
P						
Q						
R						
S						
T						

NON-PATENT DOCUMENTS

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
U	M. Takahashi, et al., "Synthesis of Fe ₁₆ N ₂ Films by Using Reactive Plasma", IEEE Tras. on Magn., 29, pp. 3040-3045.	1993
V	A. Kano, et al. "Metastable Fe nitrides with high Bs prepared by reactive sputtering", J. Applied Physics 53 (11), pp. 8332-8334.	11/1982
W		
X		